

Cobalt Silicide Nanostructures: Synthesis, Electron Transport, and Field Emission Properties

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ABSTRACT: Cobalt silicide nanostructures have been synthesized by a spontaneous chemical vapor transport and reaction method. The temperature and the vapor flow rate were shown to critically influence the growth of nanostructures. The effects of two main parameters on the growth of nanostructures were discussed. The phases formed were determined by the Gibbs free energy changes in the reactions. Various phases (CoSi, Co₂Si) and morphologies, such as single-stem nanowires, three-dimensional (3D) nanowire networks, and aloelike nanostructures, have been synthesized. Very low turn-on field (1.42 V/μm) and good conductance obtained from field-emission and electrical property measurements, respectively, indicate that CoSi nanowires are potentially useful for electronic devices.

Introduction

One-dimensional (1D) nanostructures such as nanowires (NWs), nanobelts, nanotubes, and nanorods, are attracting much interest because of their unique physical properties.^{1–3} These nanostructures are expected to play an important role as interconnects and functional units in fabricating electronic, optoelectronic, and electromechanical devices.^{4–9} Metal silicides constitute an important group of compounds that are used in silicon-based devices.^{10–12} Cobalt silicide is known to be a high-melting point material with very low resistivity, which offers the possibility of electrical interconnections in nanoscale.¹³ Cobalt silicides have been shown to be promising cold cathode materials for emission due to the high thermal and chemical stability.¹⁴ A number of metal silicide nanowires, including TaSi₂, TiSi₂, and Ni silicides nanowires, were also reported to possess excellent field-emission properties.^{15–19}

Various effective strategies have been developed for the synthesis of silicide nanowires.^{13,20–22} TiSi₂ nanowires were grown in a single direction on silicon surface by reactive deposition epitaxy.²¹ CoSi and FeSi NWs were synthesized via chemical vapor deposition (CVD) of single-source precursor and serve as building block of magnetic semiconducting Fe_{1–x}Co_xSi NWs suitable for silicon-based spintronics.^{22–24} TaSi₂ nanowires have been synthesized on a Si substrate by annealing NiSi₂ films in an ambient containing Ta vapor.¹⁵ Single-crystalline metal silicide nanowires synthesized by metal halide precursors were reported recently.^{25–30}

In this paper, we report the growth of Co₂Si and CoSi nanostructures by a spontaneous chemical vapor transport growth method. Both reaction temperature and vapor flow rate were found to critically influence the growth of nanostructures in the present study. In addition, a variety of

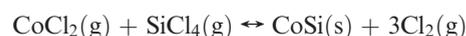
structures and morphologies of cobalt silicide nanostructures, such as single-stem CoSi and Co₂Si nanowires, 3D CoSi nanowire networks, and aloelike Co₂Si nanostructures, were grown under suitable conditions. The field emission properties of various structures and morphology of CoSi nanostructures were compared. The growth of Co₂Si and CoSi nanowires by similar synthesis methods was previously reported.^{26,31}

Experimental Section

Single crystal Si (001) wafers were used as substrates. Prior to the loading into the two-zone furnace at the atmosphere pressure with an argon (Ar) flow, the wafer was cleaned with 1%-buffered HF. The samples were placed at the downstream and the cobalt chloride powder at the upstream. The powders were heated at 600 °C and the heating zone was set at temperatures of 800–1000 °C downstream. The two heating centers were at a distance of 20 cm apart. The exact temperature of the substrate was measured with a thermocouple attached to the substrate. The temperature was ramped up from room temperature to reaction temperature in 60 min. The precursor vapors were carried by the Ar flow, which was set at 50, 150, and 300 sccm, and reacted with silicon substrates placed downstream for 2 h unless otherwise mentioned. The furnace was then allowed to cool to room temperature. The phase formation was investigated by X-ray diffraction (XRD). The morphology of products was examined with a field emission scanning electron microscope (SEM) (JSM-6500F). The phases and compositions of nanostructures were obtained with a JEOL-2010 transmission electron microscope (TEM), equipped with an energy-dispersive spectrometer (EDS). The field emission characteristics were measured with a Keithley 237 tester.

Results and Discussion

In a previous work, the pathways for CoCl₂ vapor to react with Si substrate to form CoSi nanowires were proposed as follows.²⁶



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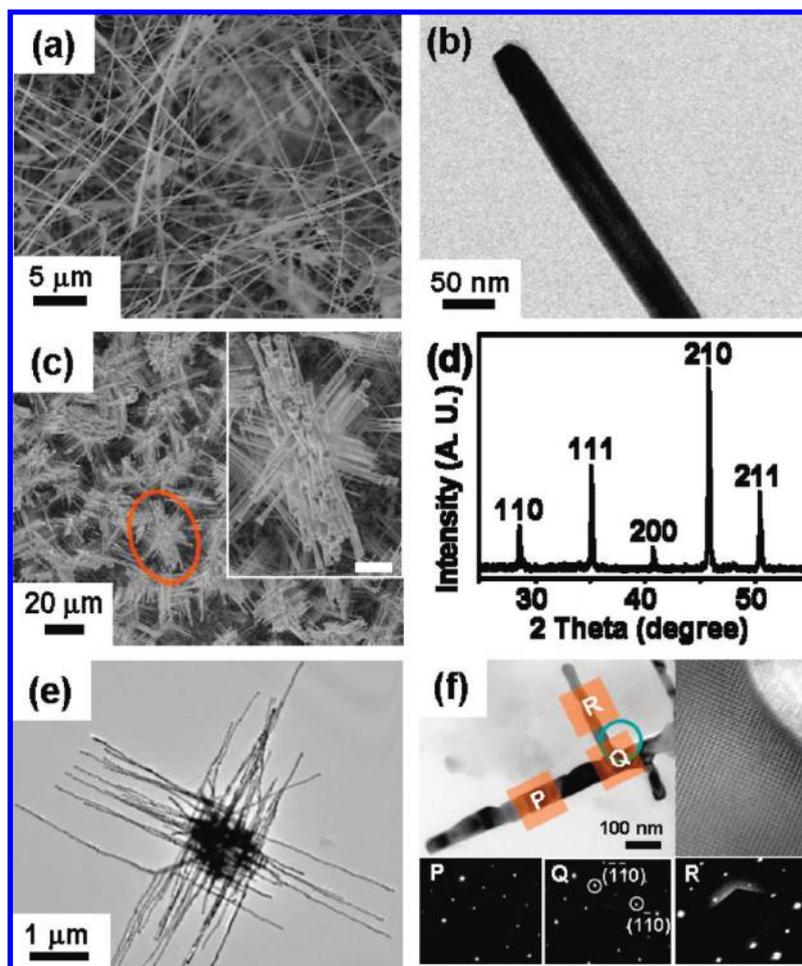
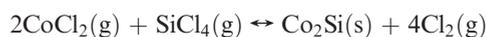


Figure 1. (a) Representative SEM image of CoSi nanowires grown at 750 °C in region A. (b) TEM image of a CoSi nanowire grown at 750 °C in region A. (c) Low-magnification SEM images of the CoSi nanowire networks grown at 780 °C in region A. Inset: High-magnification SEM image. The scale bar is 5 μm. (d) XRD pattern from a sample of CoSi nanowire networks grown at 780 °C in region A. (e) TEM images showing a complete 3D nanowire network and (f) a broken nanowire network segment grown at 780 °C in region A. Insets are the SAEDs from the regions P, Q, and R as well as HRTEM image of an intersection.

The reactions for the formation of Co₂Si nanowires are likely to follow similar pathways.



The growth processes of cobalt silicide (CoSi, Co₂Si) nanowires include two steps. First, the silicide particles were formed on the substrate. Second, self-catalyzed nanowires were grown from the silicide particles.²⁵ (see the Supporting Information, S1) By controlling the vapor pressure of the precursor and the temperature of the substrate, we can obtain a variety of structures and morphologies of the cobalt silicide (CoSi, Co₂Si) nanostructures. The morphologies are quite different at various substrate temperatures. At 610 °C, only particles and very short nanowires were observed. At 790 °C, because of the fast growth rate, the micrometer-sized particles were formed. A high density of single-stem CoSi nanowires was formed at 750 °C, as shown in Figure 1a. The diameters and lengths of the synthesized nanowires are 40–80 nm and tens of micrometer, respectively. Compared with nanowires formed at 790 °C with a diameter of about 100 nm, moderate reaction temperature is more conducive to the nucleation and growth of nanowires.

By adjusting the carrier gas flow rate, similar reaction products were obtained at the three temperatures with different Ar flow rates. In particular, the diameter of nanowires was not affected significantly by the Ar flow rate. The variation in Ar flow rates only affects the densities and lengths of nanowires. For example, decreasing Ar flow rate from 300 to 50 sccm led to the lower density and shorter nanowires. By controlling the two main parameters, the Ar flow rate and the temperature of substrate, the various morphologies of cobalt silicide (CoSi, Co₂Si) nanostructures can be obtained. The morphologies of the nanostructures and the diameter of nanowires were influenced by reaction temperature. The densities and lengths of nanowires were affected by Ar flow rate. The nanostructures formed at various temperature and flow rate are shown in the Supporting Information, S2.

The optimum synthesis condition for single-stem CoSi nanowires was realized with the heating zone set at 900 °C and Ar flow rate maintained at 300 sccm. A string of Si substrates was placed horizontally in the furnace. The temperatures of three regions in the heating zone were measured with a thermocouple attached to the samples. Apparently, the nanostructures of cobalt silicides (CoSi, Co₂Si) were influenced by a slight variation in vapor flux with the location in the furnace. The nanostructures formed at different regions

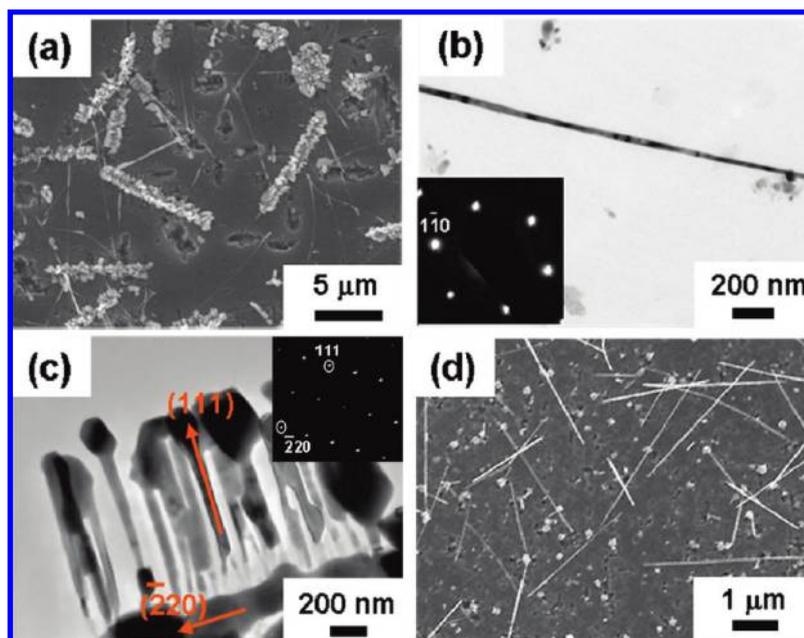


Figure 2. (a) SEM image of Co_2Si nanowires formed in region B. TEM images of (b) a single-stem nanowire and (c) aloelike nanostructures. (d) Representative SEM image of straggled CoSi nanowires grown in region C.

in the furnace with the heating zone set at 900 °C and the Ar flow rate maintained at 300 sccm are depicted in the Supporting Information, S3. Region A is the closest among the three regions to the source boat, and the vapor flux is expected to be the highest. The region at the heating center with a decreased vapor flux and the highest temperature is referred to as region B. Region C is far away from the source boat with the lower vapor flux; the temperature is close to that of A.

The samples in region A near the source boat encountered the highest vapor pressure at a temperature range of 750–830 °C. The TEM image of a single-stem nanowire grown at 750 °C in region A is illustrated in Figure 1b. The diffraction spots in the SAED pattern (not shown) can be ascribed to the cubic B20 type CoSi . The CoSi nanowire networks were synthesized at the particular zone with a higher temperature (780 °C) than that for single-stem nanowire growth. The high yield of 3D nanowire networks can be observed from the low-magnification SEM image and the morphology of 3D nanowire networks can be clearly demonstrated in a high-magnification image, as shown in Figure 1c. The size of each network is about 10–30 μm. The constituents of 3D network structure are nanowires with diameters around 100 nm in width and they intercross with each other to form the 3D networks. The peaks of the XRD from the 3D nanowire networks grown at 780 °C in region A shown in Figure 1d can all be ascribed to the CoSi phase. The TEM images of a complete 3D nanowire network and a broken nanowire network segment are shown in panels e and f in Figure 1, respectively. The angle of the junction is nearly equal to 90°. The SAED patterns were obtained from regions P, Q, and R, indicating that the entire network is single-crystalline CoSi . The nanowires P and R are grown along the $[\bar{1}\bar{1}0]$ and $[\bar{1}\bar{1}0]$ directions, respectively, and rotate by 90° with each other. HRTEM image of the intersections of the network further revealed that no dislocations were present to influence the branching growth, as shown in the inset of Figure 1f. In a previous work, branched morphology of nanowires was correlated with the high supersaturation ratio.²⁵ Accordingly,

as the Ar flow rate was decreased from 300 to 50 sccm, 3D nanowire networks were no longer grown.

The substrate in region B was positioned at the comparatively high temperature zone (880–900 °C). Two kinds of nanostructures were produced in the same area: single-stem nanowires and aloelike nanostructures. The diameter and length of the single-stem nanowires are 50–100 nm and several micrometers, respectively, as illustrated in Figure 2a. A TEM image and a SAED of single-stem nanowire are shown in Figure 2b. The SAED pattern reveals that the nanowire is single-crystalline and could be ascribed to the orthorhombic Co_2Si structure. The size of each aloelike nanostructures and the diameter of its branch are about 10 μm and 80–120 nm, respectively. The TEM image and a SAED pattern of aloelike nanostructures are shown in Figure 2c. The SAED patterns obtained for the trunk, the head and the branch of the aloelike nanostructures can also be ascribed to orthorhombic Co_2Si structure. The branches and trunk of the aloelike nanowires were found to grow along $[111]$ and $[\bar{2}20]$ directions, respectively. Notably, the discontinuous single-crystalline structure at the intersection was replaced by an amorphous layer, which suggests that amorphous silicon oxide was formed at the local regions. The results differ from the branch structure obtained at region A. The region B where aloelike nanostructures formed is located in the highest temperature zone with a diminished vapor flux compared to that of region A. The trunks of aloelike nanostructures formed first and the branches evolved from the trunk with the vapor achieving the sufficient degree of supersaturation to facilitate the growth. As the branches growth continued, amorphous silicon oxide was formed at the roots of the branches with the decreased supply of CoCl_2 vapor. Moreover, as the vapor pressure was decreased with the diminished supply of the source vapor, the branched nanowires became trimmed and appeared to be terminated with spherical end to form aloelike nanostructures. A similar morphology of nanowires with a large head was previously observed for the TiSi nanopins. The varied size of the nanopins was also explained

in terms of the diminishing source flux with time.³² The amorphous silicon oxide seen in Figure 2 is related to residual oxygen in the processing chamber. Cobalt silicide (CoSi, Co₂Si) nanostructures were synthesized in the diffusion furnace with flowing Ar. It was therefore inevitable that residual oxygen was involved in the reactions.

The Gibbs free energies of the substances are shown in the Supporting Information, S4. The Gibbs free energies of the reaction 1 at the temperatures of 750 °C (region A) and 880 °C (region B) are -1166 kJ/mol and -1158 kJ/mol, respectively. The Gibbs free energies of the reaction 2 at the temperatures of 750 °C (region A) and 880 °C (region B) are -1125 kJ/mol and -1255 kJ/mol, respectively. Consequently, reaction 1, which has the lower Gibbs free energy at a temperature at 750 °C, is the main reaction to lead to the formation of CoSi nanowires. On the other hand, Co₂Si nanowires were produced at 880 °C following the reaction 2. The phases formed were determined by the Gibbs free energy changes in the reactions.

Region C was far away from the source boat and the temperature was close to that of region A. With lower vapor pressure, straggled single-stem nanowires were formed as revealed by the SEM image. No particles and etching marks on the flat substrate surface were observed. However, the density of the smooth and straight nanowires of 40–80 nm in diameter and 4–6 μm in length was rather low, as illustrated in Figure 2d. The diameter of nanowires is identical to that in region A but somewhat shorter. The nanowires in region C are also of CoSi phase. Co₂Si nanowires were synthesized only in the region B. XRD spectrum (not shown) of products obtained from region A showed that all peaks can be ascribed to cubic structure CoSi. The result indicated that only CoSi nanowires were formed on Si substrate. No XRD data were obtained from the products in the region C because the density of straggled nanowires is very low. On the other hand, TEM analyses, including selected area electron diffraction pattern, high-resolution TEM, and energy-dispersive spectrum, of several nanowires obtained in the region C all indicated that the nanowires are single-crystalline CoSi.

Field-emission measurements were carried out in a vacuum chamber pumped to $\sim 1.0 \times 10^{-5}$ torr in pressure at room temperature and with an anode to sample distance of 180 μm. The turn-on field and threshold field are defined to be the fields required to produce a current density of 10 and 100 μA/cm², respectively. The three types of CoSi nanostructure are the high density single-stem nanowires, the 3D nanowire networks, and the straggled single-stem nanowires. The field emission data were taken from samples of 1 cm² in size and represented the average effects from different nanostructures. For 3D nanowire networks, the distances between the NW emission tips to the anode were less than 180 μm. For the same samples, the measurements were made repeatedly. Stable and reproducible J - E characteristics were only obtained for single-stem CoSi nanowires. The emission current density, J , as a function of applied field, E , is depicted in Figure 3. The turn-on fields of the high-density single-stem nanowires and the 3D nanowire networks are 1.42 and 2.20 V/μm. The threshold field of the high density single-stem nanowires is 2.05 eV. The values are much lower than the reported values of TaSi₂, TiSi₂, and Ni silicides nanowires.^{15–19} The turn-on field of the straggled single-stem nanowires was not stable and the best profile is shown in Figure 3. Compared to the 3D network structure, the turn-on field is lower and the emission current is higher for the single-stem nanowires. The Fowler–Nordheim (FN) plot of $\ln(J/E^2) - 1/E$ of the single-stem CoSi nanowires

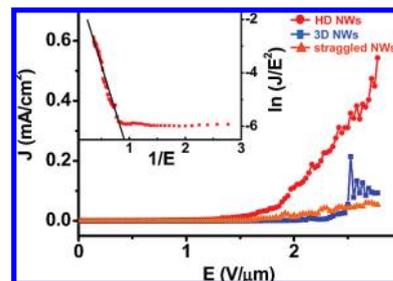


Figure 3. Field emission curves of the three type nanostructures: high density single-stem nanowires (HD NWs), the 3D nanowires networks, and the straggled single-stem nanowires. Inset: the FN plot of high density single-stem nanowires.

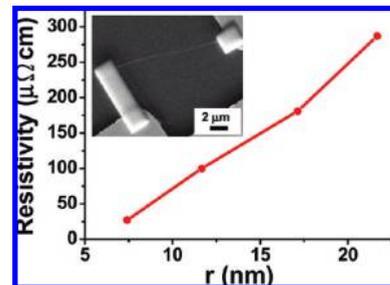


Figure 4. The curve depicting resistivity versus diameter of nanowires. Inset: the SEM image of the measurement structure.

is shown in the inset of Figure 3. By determining the slope of the FN plot, the field enhancement factor β of single-stem nanowires was calculated to be 1×10^3 , which is higher than other silicide nanowire emitters mentioned above.^{15–19} The field emission of single-stem nanowires is more efficient, homogeneous, and stable, as illustrated in Figure 3. The 3D network structure appeared to be less efficient than single-stem nanowires in current emission. For the 3D network, the sharp tips for emission are relatively scarce. Furthermore, the distribution of the electric charge in the 3D network structure may impede the emission of current at the tips as shown in Figure 3. It is worthwhile to mention that CoSi nanowires were sheathed with 3–5 nm silicon oxide. Dilute HF was used to remove the amorphous silicon oxide. However, the oxide regrew rapidly in air ambient. Therefore, the measurements of field emission properties were made for CoSi nanowires with silicon oxide sheath. The oxide coatings are expected to influence the field emission properties of nanowires. Measurement of field emission properties of Co₂Si nanowires was attempted. However, the density of nanowires was so low that no current could be detected by the instrument. Therefore, the measurements of field emission properties were limited to the CoSi nanowires with different morphologies.

In addition to the field-emission properties, the electrical properties of the CoSi single-stem nanowires were also measured. The electrical measurements were carried out for single nanowires with various diameters. Pt electrodes were deposited at both ends of nanowires with a focus ion beam system. The resistivity reduces with decreasing radius of nanowires as illustrated in Figure 4. The resistivities and diameters of the nanowires are 287, 181, 100, 27 μΩ cm and 43, 34, 23, 15 nm, respectively. The increase in conductivity with the decreasing diameter of nanowires is rather intriguing. It is attributed to the enhanced surface conductivity since the surface-to-volume ratio increases with the decreasing diameter. A previous work

showed that the resistivity of Pt₂Si NWs is about half the reported resistivity of thick Pt₂Si films. Additional conduction paths through surface or interface states on NWs were suggested to lead to the decrease in resistivity.³³

Summary and Conclusions

A variety of cobalt silicide (CoSi, Co₂Si) nanostructures were grown by a chemical vapor transport method. Notably, novel three-dimensional (3D) CoSi nanowire networks and aloelike Co₂Si nanostructures were grown under specific conditions in addition to nanowires. Both reaction temperature and vapor flow rate were found to critically influence the growth of nanostructures. The variation in Ar flow rates affected the densities and lengths of nanowires. On the other hand, the morphologies of the nanostructures and the diameter of nanowires were influenced by reaction temperature. Furthermore, the phases formed were determined by the Gibbs free energy changes in the reactions. Field-emission and electrical property measurements of CoSi nanowires show excellent performance with low turn-on field and good conductance. The CoSi nanowires are potentially useful in nanoelectronics devices.

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Note added after ASAP Publication. An earlier version of this paper was posted ASAP to the web on September 22, 2009, with an incorrect journal name in ref 10a. The reference has been corrected in this new version posted October 7, 2009.

Supporting Information Available: Additional information (PDF). This material is available free of charge via the Internet at <http://pubs.acs.org>.

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